



Docket No. 740756-2045

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Kenji ITOH et al.

)

) Group Art Unit: 1762

Serial No. 09/412,510

) Examiner: M. Padgett

Filed: October 5, 1999

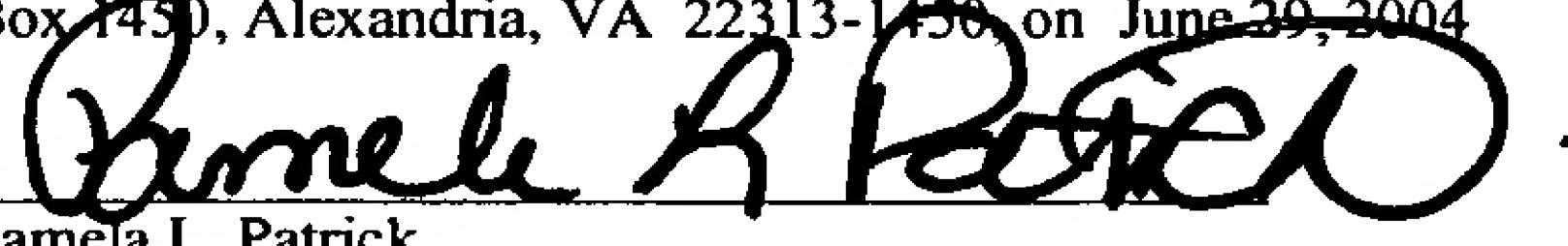
)

For: PROCESS FOR TREATING A  
SUBSTRATE WITH A PLASMA

)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on June 29, 2004.

  
Pamela L. Patrick

REQUEST FOR RECONSIDERATION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants response to the Office Action dated March 29, 2004 as follows.